

**Application Data Sheet****Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Ken
Family Name::	YOSHIZAWA
City of Residence::	Niigata
Country of Residence::	JAPAN

**Correspondence Information**

Correspondence Customer Number::	25944
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**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	A METHOD FOR PRODUCING A SILICON WAFER AND A SILICON WAFER
Attorney Docket Number::	126623
Suggested Drawing Figure::	
Total Drawing Sheets::	3
Small Entity::	No

**Representative Information**

James A. Oliff, Reg. No. 27,075	William P. Berridge, Reg. No. 30,024
Thomas J. Pardini, Reg. No. 30,411	Edward P. Walker, Reg. No. 31,450
Robert A. Miller, Reg. No. 32,771	Mario A. Costantino, Reg. No. 33,565
Kirk M. Hudson, Reg. No. 27,562	

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/009921	7/12/04

<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-278483	7/23/03	Yes
<b>Assignee Information</b>			
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome,	
City of mailing address::		Chiyoda-ku,	
State or Province of mailing address::		Tokyo,	
Country of mailing address::		JAPAN	
Postal or Zip Code of mailing address::		100-0005	